

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	) Confirmation No. 2927
Osamu Nakamura	)
Application No. 10/807,472	) Examiner: Rakesh Kumar Dhingra
Filed: March 24, 2004	) Group Art Unit: 1763
For: PLASMA TREATMENT APPARATUS	)
	) Date: August 24, 2006

**AMENDMENT AFTER FINAL REJECTION**

**MAIL STOP AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed April 24, 2006, please amend the above-captioned application as follows:

LIE:-

Please DO-NOT

enter

Rakesh  
8/29/06